

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Kiichi HAMA et al.) Group Art Unit: 1765
Application No.: 09/869,277) Examiner: L. UMEZ ERONINI
Filed: June 26, 2001))) Confirmation No. 2374
For: METHOD OF PLASMA PROCESSING)))
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	•
Sir	

AMENDMENT

In reply to the final Office Action mailed November 26, 2004, the period for response having been extended to May 26, 2005 by a Petition for Extension of Time - Three Months and fee payment filed concurrently herewith, and the period for response having been further extended by a Request for Continued Examination filed herewith, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims in this paper.

Remarks follow the amendment sections of this paper.